MAN 1 12 William 1

GP/2881
3 | IDS
Deurs

PATENT APPLICATION 5.23.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Examiner: NYA HAY 21 2001 3 2800 MAIL ROOM MASATO MURAKI ET AL. Group Art Unit: NYA Application No.: 09/733,980 Filed: December 12, 2000 For: CHARGED-PARTICLE BEAM EXPOSURE APPARATUS, CHARGED-PARTICLE BEAM EXPOSURE METHOD, CONTROL: DATA DETERMINATION METHOD, AND DEVICE MANUFACTURING METHOD May 16, 2001 USING THIS METHOD

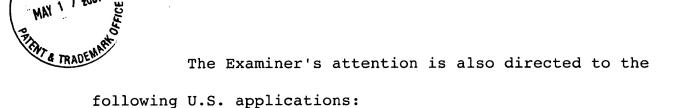
Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

)

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.



APPLICATION NO.	FILING DATE	GROUP ART UNIT
09/537,686	3/29/00	2879
09/069,748	4/30/98	2878
09/639,078	8/16/00	2878
09/733,973	12/12/00	2879

A copy of each cited Application is enclosed.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All

GIVEN CORRECTED ON THE PRADE OF TRADE O

Respectfully submitted,

Attorney for Applicants

Registration No. 29, 296

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
141834